

Notice of References Cited

Application/Control No.

10/562,884

Applicant(s)/Patent Under
Reexamination
NIEUWLAND ET AL.

Examiner

HANA A. SANEI

Art Unit

2889

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0029949	02-2005	Cillessen et al.	313/625
*	B	US-5,795,837	08-1998	Wei et al.	501/87
*	C	US-4,880,707	11-1989	Kohno et al.	428/565
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Bohn et al., Structural materials: metal-silicon-boron, Elsevier, Journal of Alloys and Compounds 347 (2002), pg. 94-100
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.